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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813  
Examiner: Jack S. J. Chen

In Re PATENT APPLICATION of:

Applicant(s): Toshikazu MIZUKOSHI

Serial No.: 10/635,506

Filed: August 7, 2003

For: METHOD OF FABRICATING A  
SEMICONDUCTOR DEVICE TRENCH  
HAVING AN OXIDE FILM ON A  
CORNERED PORTION THEREOF

Docket No.: OKI 361

AMENDMENT

ENTERED BY  
RCE  
DATED  
4/12/05

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on October 18, 2004, please  
amend the above-identified application as follows:

FEE ENCLOSED: \$  
Please charge any further  
fee to our Deposit Account  
No. 18-0002